

Application/Control No.	Applicant(s)/Patent under Reexamination		
08/416,920	MILTENYI ET AL.		
Examiner	Art Unit		
Ron Schwadron, Ph.D.	1644		

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED				
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Pour applied PCT US93/10/26	12/4/05	(M)		

391.7, 391.5, 402, 412, 413,866 424 93.7, 93.71 5

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